



**ELECTRONIC COPY**

LG669434311  
Report verification at igi.org



December 12, 2024

IGI Report Number **LG669434311**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **8.19 X 5.69 X 3.87 MM**

**GRADING RESULTS**

Carat Weight **1.57 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

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Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

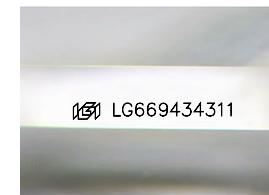
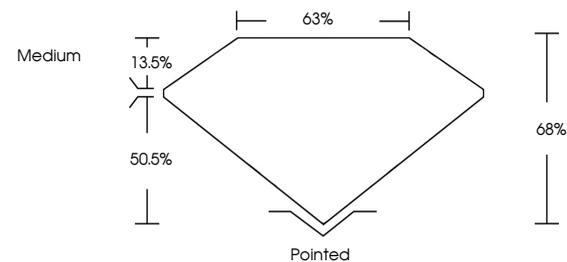
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG669434311**

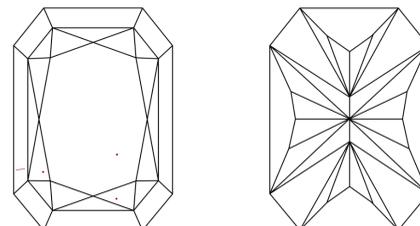
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

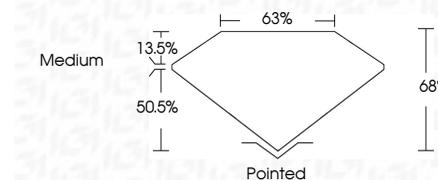
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	WS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



December 12, 2024	IGI Report No. LG669434311	CUT CORNERED RECT. MODIFIED BRILLIANT	8.19 X 5.69 X 3.87 MM	1.57 CARAT	E	VS 1	68%	63%	Medium	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG669434311
				Carat Weight	Color Grade	Clarity Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)

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